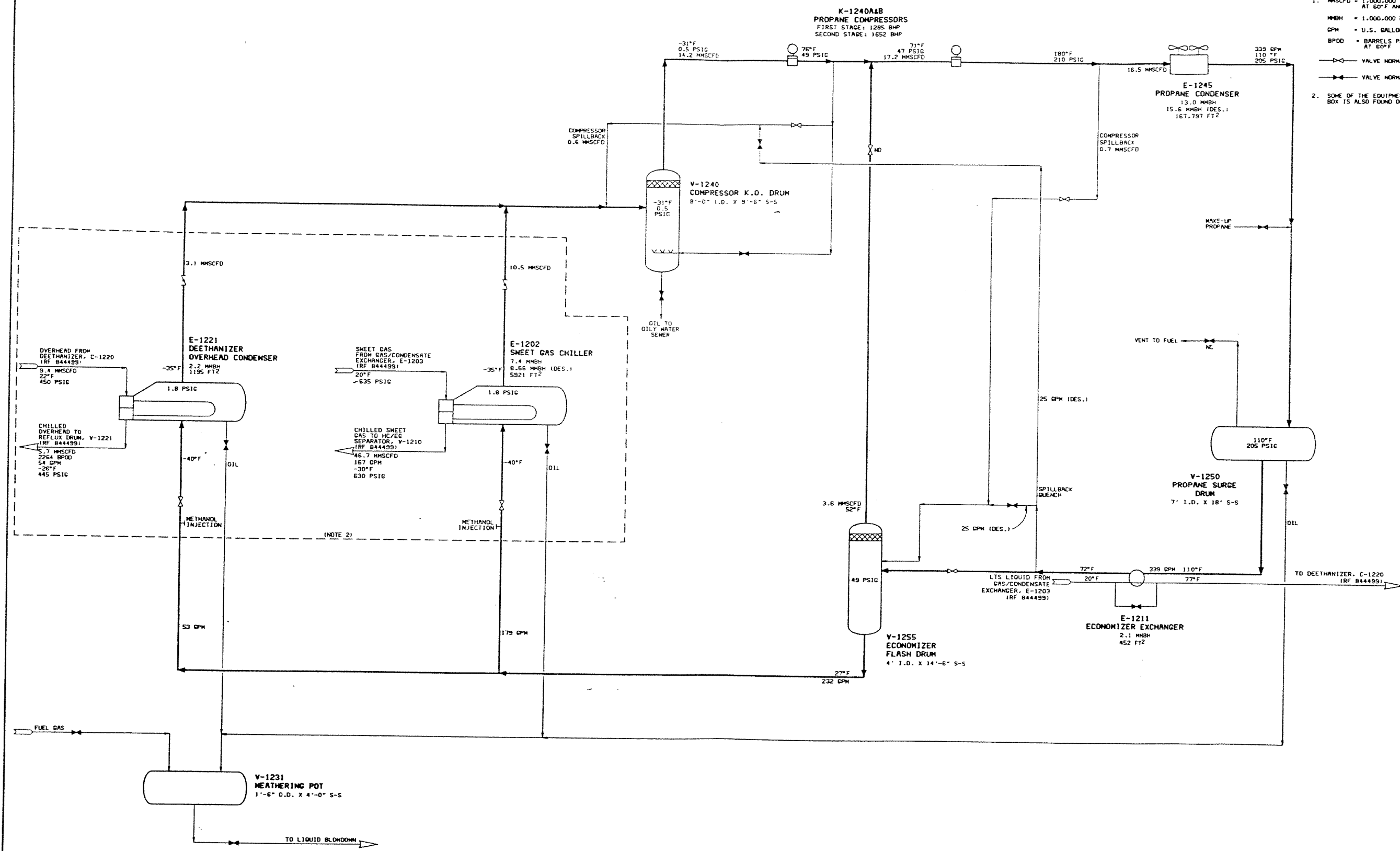


- NOTES:
1. MMSCFD = 1,000,000 STD CU FT PER DAY AT 60°F AND 14.7 PSIA.
MMBH = 1,000,000 BTU/HR
GPM = U.S. GALLONS/MIN. AT FLOW
BPOD = BARRELS PER OPERATING DAY AT 60°F
 2. SOME OF THE EQUIPMENT SHOWN IN THE BOX IS ALSO FOUND ON Dwg. RF 844499.



REFERENCE DRAWINGS:
RF 844499 - PROCESS FLOW DIAGRAM - LOW TEMPERATURE SEPARATION AND DEETHANIZER
RF 844503 - PROCESS FLOW DIAGRAM - FRACTIONATION SYSTEM

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			ENG. SAC

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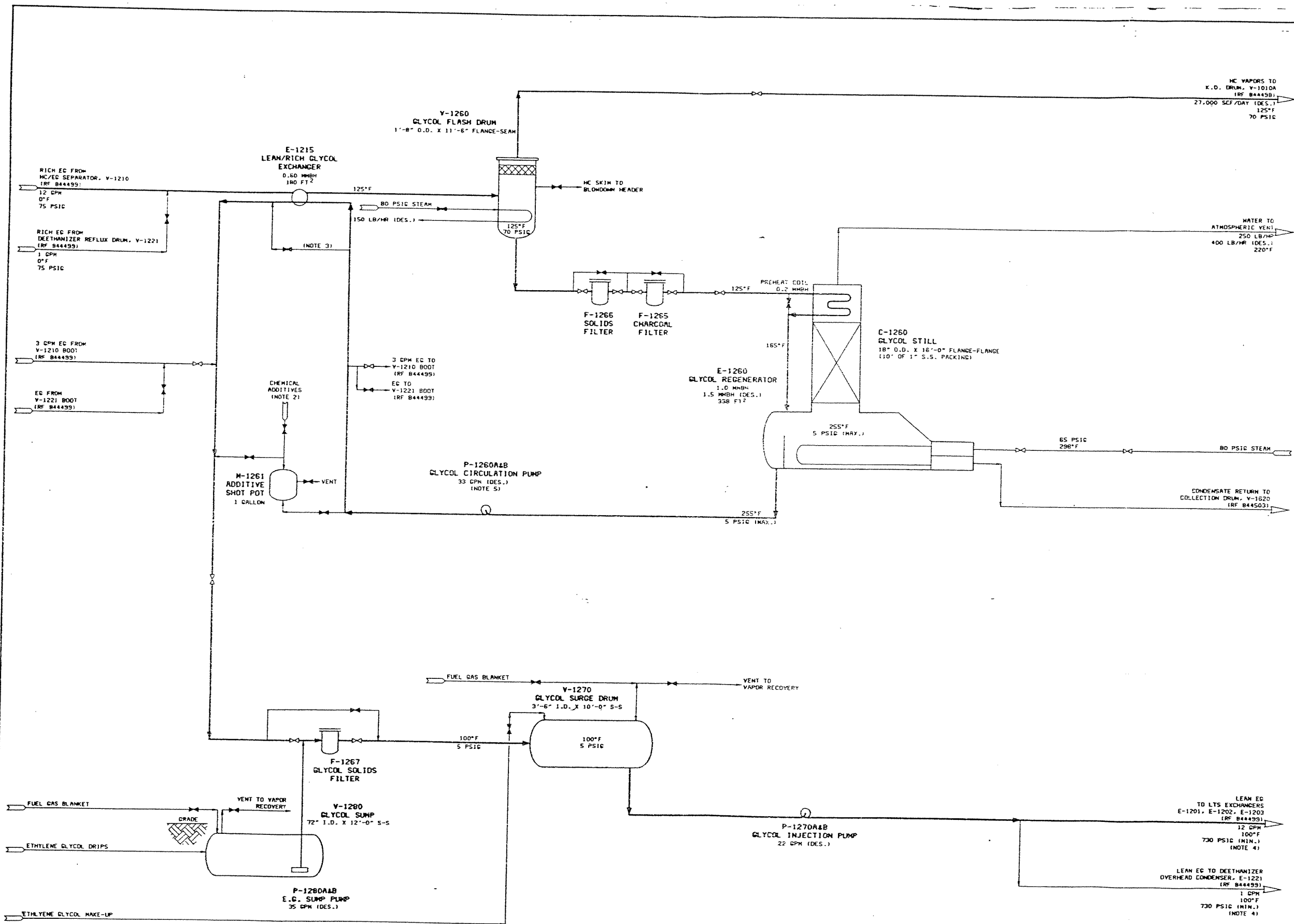
SIMPLIFIED PROCESS FLOW DIAGRAM
PROPANE REFRIGERATION SYSTEM
PLANT 12 - GAS PROCESSING SECTION
GAVIOTA GAS PLANT

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NOTES:

1. MMSCFD = 1,000,000 STD CU FT PER DAY AT 60°F AND 14.7 PSIA
MMBH = 1,000,000 BTU/HR
GPM = U.S. GALLONS/MIN. AT FLOW
BPDD = BARRELS PER OPERATING DAY AT 60°F
 - VALVE NORMALLY OPEN
 - ◐ VALVE NORMALLY CLOSED
2. CHEMICAL ADDITIVES INCLUDE ANTIFORM AND CORROSION INHIBITOR.
3. ETHYLENE GLYCOL MAY BE BYPASSED WHEN EXCHANGER IS CLEAN TO KEEP TEMPERATURE OF LEAN EC ABOVE 75°F.
4. LEAN ETHYLENE GLYCOL IS MAINTAINED AT 75 WTS CONCENTRATION TO PREVENT HYDRATE FORMATION. THE CONCENTRATION OF RICH EC SHOULD NOT BE ALLOWED TO DROP BELOW 7% WT %.
5. LEAN ETHYLENE GLYCOL CIRCULATION WILL BE TURNED DOWN DURING INITIAL PLANT OPERATION TO A MINIMUM OF 6 GPM.



REFERENCE DRAWINGS:
 RF 844498 - PROCESS FLOW DIAGRAM - INTAKE COMPRESSION
 RF 844499 - PROCESS FLOW DIAGRAM - LOW TEMPERATURE SEPARATION AND DEETHANIZER
 RF 844503 - PROCESS FLOW DIAGRAM - FRACTIONATION SECTION

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SIMPLIFIED PROCESS FLOW DIAGRAM
 ETHYLENE GLYCOL REGENERATION SYSTEM
 PLANT 12 - GAS PROCESSING SECTION
 GAVIOTA GAS PLANT

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